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NATHE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Confirmation No. 4006

Kouji TAKEZOE et al.

Attorney Docket No. 2004 0454A

Serial No. 10/807,276

Group Art Unit 2813

Filed March 24, 2004

Examiner Monica D. Harrison

METHOD FOR MANUFACTURING

Mail Stop AMENDMENT

SEMICONDUCTOR CHIP

AMENDMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Responsive to the Office Action of January 9, 2006, please amend the above-identified application as follows.